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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Group Art Unit: 2812

Wan-Thai Hsu, et al.

Examiner: H. JEY TSAL

Serial No.: 10/625,992

Filed: July 24, 2003

For: METHOD FOR MAKING MICROMECHANICAL
STRUCTURES HAVING AT LEAST ONE LATERAL,
SMALL GAP THEREBETWEEN AND
MICROMECHANICAL DEVICE PRODUCED THEREBY

Attorney Docket No.: UOM 0210 PUSP1

AMENDMENT UNDER 37 C.F.R. § 1.111

Mail Stop Amendment
Commissioner for Patents
U.S. Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed July 12, 2004, please amend the above-identified application as follows:

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this paper, including all enclosures referred to herein, is being deposited with the United States Postal Service as first-class mail, postage pre-paid, in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450.

July 29, 2004

Date of Deposit

David R. Syrowik

Name of Person Signing

Signature